

## Possibility of Doping CuGaSe<sub>2</sub> *n*-Type by Hydrogen


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Copper-indium-gallium-selenide (CIGS) alloys are successfully applied in thin-film solar cells. For a better use of the solar spectrum, they also offer the possibility of multijunction devices by tuning the composition in the different layers. As-grown CIGS is intrinsically *p*-type due to copper vacancies ( $V_{\text{Cu}}$ ), but *n*-type doping is also useful for applications. While CuInSe<sub>2</sub> can be easily turned *n*-type, CuGaSe<sub>2</sub> cannot, and this represents a problem, because increasing the band gap of CIGS requires a high Ga/In ratio. Investigating the effect of hydrogen on CuGaSe<sub>2</sub> by an optimized hybrid functional, we show that hydrogenation from an atomic source as, e.g., by a hydrogen plasma treatment, can turn the material *n*-type due to the formation of shallow donor  $V_{\text{Cu}}+2\text{H}$  complexes, while H<sub>2</sub> implantation, producing an internal hydrogen reservoir, can be used to produce semi-insulating material. We also show that under normal process conditions, unintentional hydrogen incorporation does not have a significant effect on CuGaSe<sub>2</sub>.

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### I. INTRODUCTION

The usage of photovoltaic solar energy is increasing in recent years. The second generation of thin-film solar cells based on Cu(In, Ga)(Se, S)<sub>2</sub>, or CIGS for short, has achieved a record efficiency of 23.3% [1,2], and is one of the main competitors to silicon cells with respect to efficiency and cost. In addition, CIGS is also advantageous for application in multijunction solar cells, since the gap of the different layers can be tuned by varying the ratio of In and Ga, and/or S and Se. Point defects and impurities, which may act as dopants, traps, or recombination centers, play a critical role in the photovoltaic properties of the material [3–7]. CIGS alloys are intrinsically *p*-type, however, CuInSe<sub>2</sub> can easily be doped *n*-type while effective *n*-type doping of CuGaSe<sub>2</sub> is apparently not possible [8]. Theoretical calculations confirm that *n*-type doping by substitution on cation or anion sites in CuGaSe<sub>2</sub> is not feasible [9]. This may pose a problem in an alloy where a high Ga/In ratio is needed to increase the gap.

Hydrogen is often used to passivate dangling bonds in semiconductors to eliminate the associated traps (e.g., amorphous silicon solar cells do not even work without

approximately 10% H content) [10,11], but it can also be used to passivate dopants to create semi-insulating material [12,13]. Hydrogen may also provide shallow levels, compensating the intentional dopants or even change the type of conductivity, as proposed, e.g., in CuInSe<sub>2</sub> [14]. Considering this versatility of hydrogen, it is helpful to explore its effect in CIGS materials systematically. Here we investigate that in CuGaSe<sub>2</sub>. Such a study should consider both the effect of unintentional contamination and also the active introduction of hydrogen for defect engineering. Hydrogen may get incorporated into CIGS unintentionally during growth (because the applied CdS buffer layer usually has a high hydrogen content), in nonvacuum processing steps, or during heat treatment or rapid thermal annealing in H<sub>2</sub> (to remove oxygen and improve material quality) [15–18]. It can be introduced intentionally, e.g., by implantation [19,20] or annealing in a hydrogen plasma. Hydrogen can exist in the crystal as an individual interstitial H atom or as a H<sub>2</sub> molecule, but can also form complexes with native defects and dopants. As a consequence, hydrogen can influence the electrical activity of the intrinsic defects and introduce H-related donors or acceptors as well. All that may affect the intrinsic *p*-type behavior, therefore, a systematic and detailed study of H-related defects in CuGaSe<sub>2</sub> is necessary to explore the possibility of changing the conductivity to *n*-type.

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Earlier, using the local density approximation (LDA) to density-functional theory (DFT), Kiliç and Zunger found [14,21] that H passivates the copper vacancy ( $V_{\text{Cu}}$ ), which is the main shallow acceptor in intrinsic CIGSe, and that interstitial H is a deep negative- $U$  defect. They also predicted that hydrogenation of the defect complex between two copper vacancies and a cation antisite,  $(2V_{\text{Cu}}+\text{In}_{\text{Cu}})^0$ , gives rise to a shallow donor, which makes  $\text{CuInSe}_2$   $n$ -type. In contrast, they found the complex of  $(2V_{\text{Cu}}+\text{Ga}_{\text{Cu}})^0$  with hydrogen to be a deep donor in  $\text{CuGaSe}_2$ , and no  $n$ -type doping by hydrogenation of this material. It should be noted though that the decoration of the remaining dangling bonds of  $V_{\text{Cu}}$  with H atoms have not been considered (only the addition of  $\text{H}_2$  molecules to  $V_{\text{Cu}}+\text{H}$ ) [21], while vacancies in other semiconductors can accommodate up to four H atoms [22], and the arising defects may be electrically active [23]. Hydrogenation of the antisites has not been investigated either, even though they influence the carrier concentration [9,24].

Here, we study the effect of H on all relevant defects in  $\text{CuGaSe}_2$  (CGSe) with an optimized hybrid functional, which reproduces the band gap and complies with the generalized Koopmans theorem (GKT), thereby allowing for an accurate determination of defect levels [25]. We find that the antisites can be partially or fully passivated by one or two hydrogen atoms, respectively. A single hydrogen atom can fully passivate the  $V_{\text{Cu}}$  acceptor, however an additional H atom turns it into a shallow donor, while further hydrogenation of  $V_{\text{Cu}}$  is not favored energetically. We calculate the charge transition levels of all intrinsic defects before and after hydrogenation, and use those to determine the position of the Fermi level, considering different methods of hydrogenation. We find that hydrogen does not get easily incorporated during usual process steps, but hydrogen implantation can produce semi-insulating material, while a hydrogen plasma treatment (providing H atoms as a source for hydrogenation) can turn  $\text{CuGaSe}_2$   $n$  type.

Our paper is organized as follows. The computational framework is introduced in Sec. II A, while, Sec. II B describes the choice of chemical potentials for the calculation of the formation energies. Section III describes the H-related defects, their charge transition levels, and their effect on the equilibrium position of the Fermi level, based on the calculated formation energies. The conclusions are drawn in Sec. IV.

## II. COMPUTATIONAL FRAMEWORK

### A. Methods

Figure 1 shows the 16-atom, body-centered, tetragonal conventional cell of CGSe, as well as the  $2 \times 2 \times 2$  supercell (with 128 atoms), which we use for defect calculations. In this system, the cations are tetrahedrally coordinated by

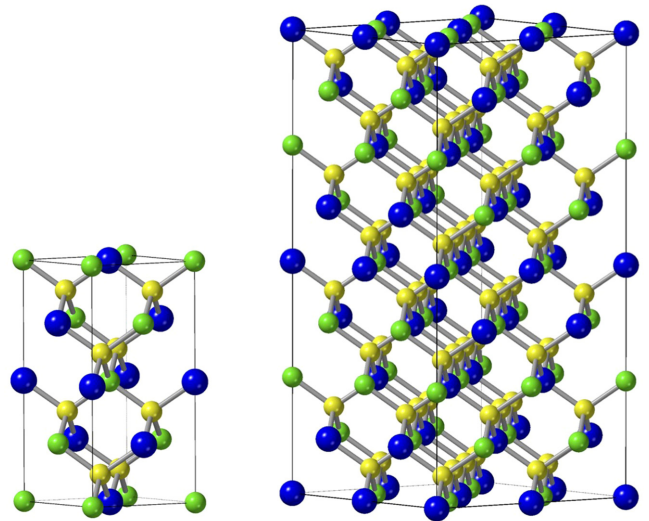


FIG. 1. The 16-atom and 128-atom cell of  $\text{CuGaSe}_2$ . Cu, blue; Ga, green; Se, yellow spheres.

four Se atoms, and the anions are surrounded by two Cu and two Ga atoms.

Calculations are carried out by the Vienna *ab initio* simulation package, VASP 5.3.5 [26–28]. The projector augmented wave (PAW) method is applied [29,30] and the Ga3d electrons are treated as part of the core, since our tests show that they have negligible effects on the band gap. (The Cu3d electrons are, of course, treated in the valence shell.) A 400- (800-) eV cutoff is applied for the expansion of the wave functions (charge density). All geometries are relaxed until the forces on every atom are less than 0.02 eV/Å. Defect calculations are carried out with spin polarization.

The standard implementations of DFT, as LDA or generalized gradient approximation (GGA), underestimate the band gap. The Heyd-Scuseria-Ernzerhof hybrid functional [31,32], with the standard parametrization (HSE06), increases the gap but in CIGS it still underestimates it and does not comply with the GKT, i.e., with the independence of the Kohn-Sham energy levels from their occupation [33]. If the double criterion of reproducing the gap (proper derivative discontinuity of the total energy as a function of the occupation number) and satisfying the GKT (linear behavior between two integer numbers) are met, highly accurate defect levels can be obtained [34–36]. It has been shown that simultaneously tuning the two parameters of a  $\text{HSE}(\alpha, \mu)$  functional (where  $\alpha$  and  $\mu$  are the mixing and screening parameter, respectively), the two conditions can be fulfilled [25,37]. Such a functional mimics the exact density functional, guaranteeing high accuracy in the ionization energies and in the localization of states [38]. Our previous work has shown that  $\text{HSE}(0.26, 0.08)$  is optimal for  $\text{CuGaS}_2$  [39]. The optimal parameters are generally material dependent, however, we find that the parameters

optimized for CuGaS<sub>2</sub> are transferable to CuGaSe<sub>2</sub>. As shown in Table I, using HSE(0.26,0.08) the GKT is satisfied within 0.02 eV in CuGaSe<sub>2</sub> too, and the band gap of 1.76 eV also appears to be appropriate, considering the experimental optical gap of 1.73 eV at 77 K [43,44]. (The fulfillment of the GKT is checked for the donor level of the relaxed neutral Sn<sub>Ga</sub> defect in a 128-atom supercell with experimental lattice parameters [45].) The accuracy of this functional has been validated by comparison to the experimentally observed, Ga<sub>Cu</sub>-related photoluminescence band in CuGaSe<sub>2</sub> [39], as shown also within the Supplemental Material [46], where the effect of optimization is also demonstrated.

We use this optimized hybrid to determine the equilibrium lattice parameters of the primitive cell, with a  $6 \times 6 \times 6$  Monkhorst-Pack (MP)  $k$ -point set [48], performing constant volume relaxations and then fitting to Murnaghan's equation of state [49,50]. Defect calculations are all carried out using these equilibrium lattice parameters ( $a = 5.646$  Å,  $c = 11.044$  Å) in the 128-atom supercell, with the  $\Gamma$  approximation for Brillouin-zone sampling.

The formation energy of a defect in charge state  $q$  is calculated as [51,52]

$$\Delta E_{\text{form}}^q(\text{defect}) = E_{\text{defect}}^q + E_{\text{corr}}^q - E_{\text{host}} - \sum_i n_i \mu_i + q(E_F - E_V + \Delta V_{\text{align}}), \quad (1)$$

where  $E_D^q$  and  $E_{\text{host}}$  are the calculated total energy of the supercell with and without defect,  $n_i$  is the number of atoms, of type  $i$ , introduced into the supercell when forming the defect, and  $\mu_i$  is their chemical potential.  $E_F - E_V$  is the Fermi energy, referenced the VBM in the bulk.  $\Delta V_{\text{align}}$  is the potential alignment between the neutral defect and the perfect cell, and  $E_{\text{corr}}^q$  is the energy correction required for charged defects in a periodic model [53]. Charge corrections for the total energy are obtained by using the method of Freysoldt, Neugebauer, and Van de Walle [54], while localized defect levels are corrected using the relation,  $e_{\text{corr}}^q = -2E_{\text{corr}}^q/q$ , derived by Chen and Pasquarello [55]. For these corrections the directional average of the experimental high-frequency dielectric constant  $\epsilon_\infty$  (7.47

for CuGaSe<sub>2</sub>) [56] is used, both for vertical (fixed ions) and adiabatic (relaxed ions) charge transitions. In principle, in the latter case the static dielectric constant  $\epsilon_0$  should be used, however, earlier we observe that in cases where  $\epsilon_0 \gg \epsilon_\infty$ , much too shallow adiabatic charge transition levels are obtained this way, while using  $\epsilon_\infty$  reproduces the experimental values better [31,57,58]. The explanation probably is that a relatively large supercell describes a substantial part of the ionic screening explicitly, and using the bulk value of  $\epsilon_0$  amounts to double counting.

Assuming thermodynamic equilibrium, the concentration of the defects in their different charge states can be estimated from the calculated formation energies, and by solving the neutrality equation for the Fermi energy:

$$N_C \exp\left(-\frac{E_C - E_F}{kT}\right) + \sum_i |q_i| N_{A_i}^q = N_V \exp\left(-\frac{E_F - E_V}{kT}\right) + \sum_i |q_i| N_{D_i}^q, \quad (2)$$

where  $E_C - E_F$  is the Fermi-level position with respect to the conduction-band minimum (CBM),  $N_{D_i}^q$  and  $N_{A_i}^q$  are the concentration of (all types of) ionized donors and acceptors, respectively, as determined by their formation energy (i.e., neglecting entropy effects):

$$N_{A_i, D_i}^q = N_0 \exp\left[-\frac{\Delta E_{\text{form}}^q(A_i, D_i)}{kT}\right]. \quad (3)$$

$N_C$  ( $N_V$ ) is the effective volume-density of states at the conduction- (valence-) band edge, and  $N_0$  is the density of defect sites in the crystal for the given defect [59]. Since the concentration of charged defects is dependent on the Fermi level through the formation energy, Eqs. (1)–(3) have to be solved self-consistently in an iterative procedure. We set the temperature to 750 K, which is a typical temperature for annealing CuGaSe<sub>2</sub> [19].

## B. Stability region

The formation energy of defects depends on the chemical potential of the elements and of the electrons (Fermi

TABLE I. Calculated band gaps of 128-atom CuGaS<sub>2</sub> and CuGaSe<sub>2</sub> supercells, compared to experiment, and the Koopmans test for Sn<sub>Ga</sub> with HSE(0.26,0.08).

	$E_g(\text{calc.})$	$E_g(\text{expt.})$	$\text{KS}_{\text{HOMO}}(N)$	$E_N - E_{N-1}$	$\text{KS}_{\text{LUMO}}(N-1)$
CuGaS <sub>2</sub>	2.55	2.53 (2 K) [40–42]	−1.55	−1.56	−1.57
CuGaSe <sub>2</sub>	1.76	1.73 (77 K) [43,44]	−0.90	−0.89	−0.87

The Kohn-Sham level of the occupied defect state (HOMO) in the neutral system,  $\text{KS}_{\text{HOMO}}(N)$ , and of the unoccupied defect level (LUMO) in the positive charged state,  $\text{KS}_{\text{LUMO}}(N-1)$ , are compared to the self-consistently calculated electron-removal energy (at fixed geometry),  $E_N - E_{N-1}$ . All three are referenced to the conduction-band minimum and given in eV. Fulfillment of the GKT requires all three values to be equal.

TABLE II. Energy of the atoms ( $E_A$ ) calculated by HSE(0.26,0.08), the experimental atomization energy ( $-E_{\text{coh}}$ ), and the corresponding chemical potential  $\mu_i^{\text{standard}}$  used in this work. All values in eV.

	$E_A$	$-E_{\text{coh}}^{58}$	$\mu^{\text{standard}}$
Cu	-0.71	3.49	-4.20
Ga	-0.86	2.82	-3.68
Se	-2.41	2.44	-4.85
H	-1.77	2.26	-4.03

energy) as given in Eq. (1). The chemical potential of element  $i$  in a reservoir is expressed as  $\mu_i = \mu_i^{\text{standard}} + \Delta\mu_i$ , where  $\mu_i^{\text{standard}}$  is the chemical potential in the standard chemical state and  $\Delta\mu_i$  is the deviation from that under given experimental conditions. The HSE hybrid does not work well for metals and must be optimized for each semiconductor separately, therefore, to obtain  $\mu_i^{\text{standard}}$ , we calculate the energy of the atoms with HSE(0.26,0.08), and then deduct the experimental atomization energy (negative of the cohesion energy) [60]. Table II shows the values we use.

$\Delta\mu_i$  can be varied to reflect specific conditions. In thermal equilibrium, however,

$$\Delta\mu_{\text{Cu}} + \Delta\mu_{\text{Ga}} + 2\Delta\mu_{\text{Se}} = \Delta H_f^{\text{CuGaSe}_2}. \quad (4)$$

To avoid the precipitation of elemental solids, the chemical potentials should be bound by

$$\Delta\mu_{\text{Cu}} \leq 0; \Delta\mu_{\text{Ga}} \leq 0; \Delta\mu_{\text{Se}} \leq 0. \quad (5)$$

The chemical potentials are further restricted by the formation of unwanted competing binary phases like GaSe, CuSe, Cu<sub>2</sub>Se, Cu<sub>3</sub>Se<sub>2</sub>, and the ordered defect compound Cu<sub>5</sub>GaSe<sub>8</sub>. The chemical potential region, where CuGaSe<sub>2</sub> is stable, is shown in Fig. 2 with light-blue shading. To set up the phase diagram, we use the experimental formation enthalpies of the compounds (see Table III), because, again, the hybrid optimized for CuGaSe<sub>2</sub> may not be optimal for the other compounds.

In Fig. 2 three points are specified, to represent Cu-poor (A), Ga-poor (B) and Se-poor (C) conditions. These are used for discussing defect physics. Since high-efficiency Cu(In,Ga)Se<sub>2</sub> absorbers are generally prepared under a highly selenium-rich atmosphere, it is instructive to interpret the defect physics for this material under selenium-rich conditions on the Se-Cu(In,Ga)Se<sub>2</sub> phase boundary in the stability diagram (between A and B points). In addition, the chemical potential of copper between A and B agrees well with the measured value of -0.5 to -0.7 eV in high-quality Se-rich Cu(In,Ga)Se<sub>2</sub>.

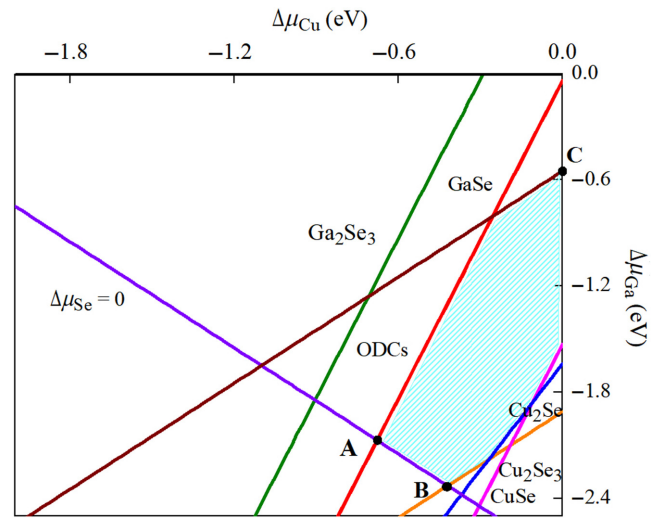


FIG. 2. Stability diagram for CuGaSe<sub>2</sub>, as derived from the data in Table II. The chemical potentials of Cu, Ga, and Se at point A are (-0.68, -2.07, 0), at B (-0.42, -2.33, 0) and at C (0, -0.55, -1.1), respectively. All values in eV.

### III. RESULTS

To study the effect of hydrogen on CuGaSe<sub>2</sub>, we investigate H<sub>i</sub> and H<sub>2i</sub> interstitials as well as the complexes of hydrogen with the most abundant intrinsic defects, ( $V_{\text{Cu}}+n\text{H}$ ), ( $\text{Ga}_{\text{Cu}}+n\text{H}$ ), and ( $\text{Cu}_{\text{Ga}}+n\text{H}$ ). For a single hydrogen atom, four interstitial starting positions are considered: the Cu—Se and the Ga—Se bond-center (BC) site, as well as the tetrahedral sites surrounded by cations (TC) or anions (TA). As shown in Fig. 3, for H<sup>-</sup> the global energy minimum is at the so-called antibonding (AB) site, behind a Cu atom, while H<sup>+</sup> prefers the BC site between Cu and Se.

It can be inferred that H<sup>+</sup> behaves as a cation, bonding to the anion Se, while H<sup>-</sup> behaves as an anion, preferentially binding to the more electronegative cation Cu. These ionic bonds are quite strong, so H<sup>0</sup> is always less stable than either H<sub>AB}^- or H<sub>BC}^+. Neutral hydrogen placed into  $V_{\text{Cu}}$  moves to bind with a Se neighbor [Fig. 3(c)].</sub></sub>

$\text{Ga}_{\text{Cu}}$  is a double donor [24,39], so hydrogen binds to it as an anion in the AB position, while  $\text{Cu}_{\text{Ga}}$  is a double

TABLE III. Experimental formation energies of the compounds relevant to the stability diagram.

Compound	$\Delta H_f$
CuGaSe <sub>2</sub>	-2.75 [61]
GaSe	-1.65 [62]
CuSe	-0.42 [61]
Cu <sub>2</sub> Se	-0.61 [61]
Cu <sub>3</sub> Se <sub>2</sub>	-1.03 [63]
Cu <sub>5</sub> GaSe <sub>8</sub>	-10.96 (HSE06)

All values in eV.

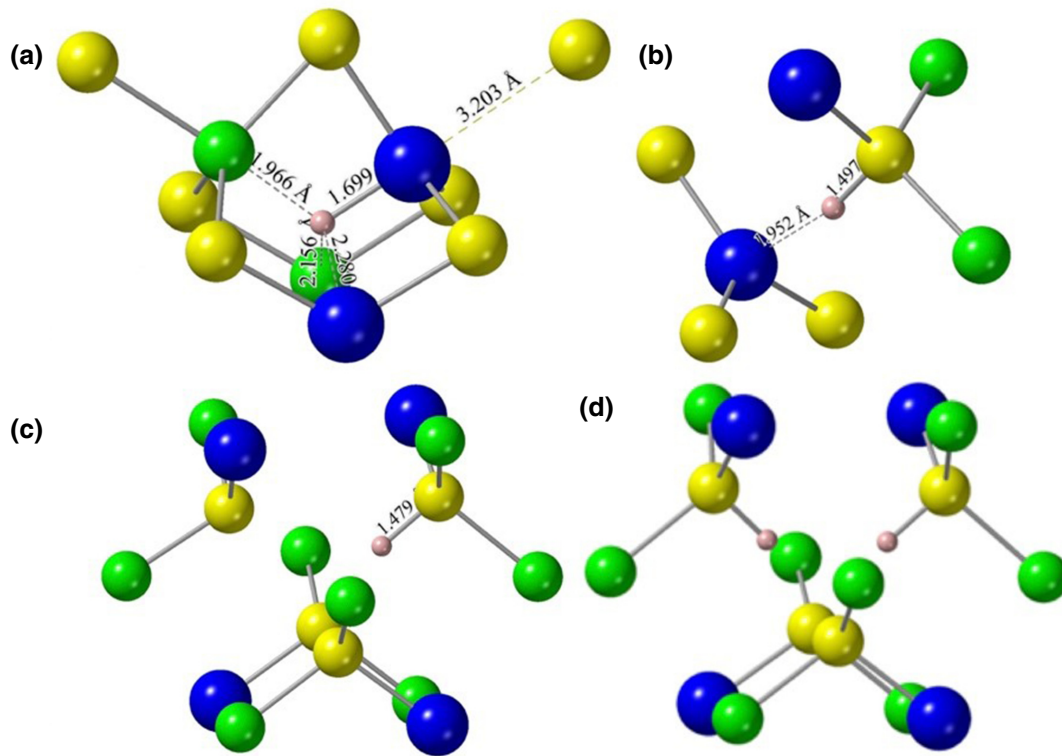


FIG. 3. Stable configuration for the (a) negative ( $H_{AB}^-$ ) and (b) positive ( $H_{BC}^+$ ) interstitial, as well as for the (c)  $V_{Cu}+H$  and (d)  $V_{Cu}+2H$  defects. Cu, blue; Ga, green; Se, yellow spheres.

acceptor [24,39], so hydrogen behaves as a cation going to the BC site again and binding to the Se neighbor of  $Cu_{Ga}$ , as shown in Fig. 4. As a consequence, the double donor and the acceptor are partially passivated, becoming a single donor and acceptor, respectively. Using simple electron-counting arguments it is easy to see that  $Ga_{Cu}+H$  is a shallow donor. Out of the three electrons, which the four Se neighbors would (nominally) donate to copper, and the three electrons of  $Ga_{Cu}$ , four are used to create the four bonds of  $Ga_{Cu}$  (to its three Se neighbors and to  $H_{AB}$ ), the fifth turns the dangling bond of the fourth Se neighbor into a lone pair orbital (deep in the VB), and the remaining electron finds only place on the CBM. This is confirmed by the actual calculation.

For  $H_{2i}$ , we consider the  $H_2$  molecule at the TA and TC sites, as well as the  $H_{BC}H_{AB}$  (also called  $H_2^*$ ) complex [64,65], with  $H_{AB}^-$  bonded to Cu and  $H_{BC}^+$  bonded to Se ( $Se-H...Cu-H$ ), which is an electrically passive defect. As it turns out,  $H_{2i}$  at the TC site is preferred energetically by far.

As can be seen in Fig. 3(c), the three other Se dangling bonds of  $V_{Cu}+H$  offer the possibility of further hydrogen uptake. Since the acceptor  $V_{Cu}$  is electrically passivated by a single hydrogen, addition of further H atoms may turn it into a donor. Using electron-counting again, in the case of  $V_{Cu}+2H$ , two Se dangling bonds are saturated by the

hydrogens, while the other two become lone pair orbitals (deep in the VB) accommodating two of the three electrons the four Se neighbors would (nominally) donate to copper. The third electron is forced onto CBM here too. This is confirmed by the actual calculation. Further hydrogenation would only place more electrons onto the CBM, so that is energetically not favorable, as we indeed find.

When  $Ga_{Cu}+H$  forms,  $Ga_{Cu}-Se$  bond gets broken [see Fig. 4(a)]. One would expect that upon adding one more H atom, a  $H_{BC}H_{AB}$ -type defect (with  $H_{BC}$  bonded to Se) will form. However, a complex of  $(Ga_{Cu}+H)^+$  and a  $H_{AB}^-$  interstitial behind a next-neighbor Ga site [see Fig. 5(a)] is energetically more favorable, because the donor electron of  $Ga_{Cu}+H$  is transferred to the interstitial H. This way  $Ga_{Cu}+H$  is passivated and further hydrogen atoms would go to remote interstitial sites.  $Cu_{Ga}+H$  offers the possibility of inserting an additional  $H_{BC}^+$  to bond with another Se neighbor of  $Cu_{Ga}$ , as shown in Fig. 5(b). With that the antisite defect is fully passivated and the increasing lattice strain makes adding further hydrogens energetically unfavorable.

Having obtained the stable defect configurations, we calculate their charge transition levels, which determine their electrical activity. These are summarized in Fig. 6. Interstitial H is found to exhibit a negative- $U$  behavior with a  $(+/-)$  level at 1.33 eV above the VBM, which is

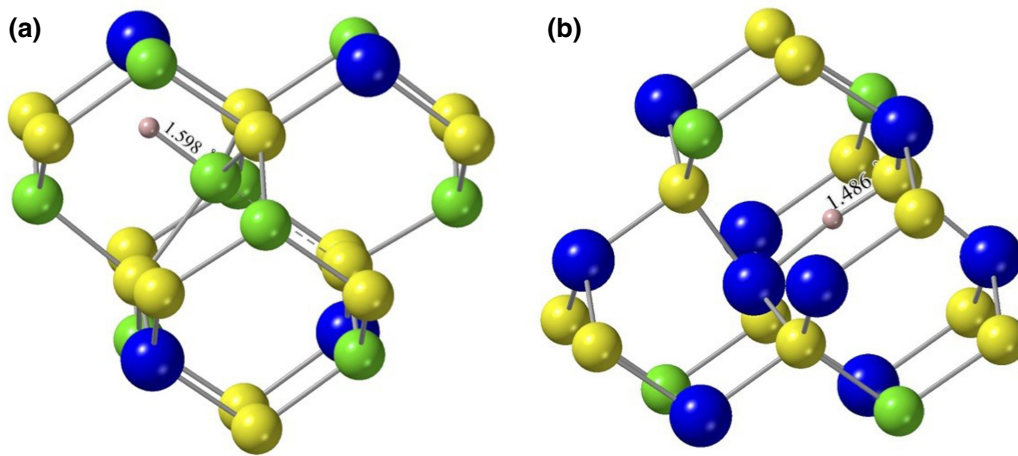


FIG. 4.  $\text{Ga}_{\text{Cu}}+\text{H}$  (a) and the  $\text{Cu}_{\text{Ga}}+\text{H}$  (b) complexes in the neutral charge state.

more or less the same as in previous calculations [14,66]. Interstitial  $\text{H}_{2i}$  is electrically inactive. The single acceptor  $V_{\text{Cu}}$  is passivated by hydrogen, so the  $V_{\text{Cu}}+\text{H}$  complex is electrically inactive as well. As explained above, however, an additional hydrogen turns it into a shallow effective-mass-like (EMT) single donor.  $\text{Cu}_{\text{Ga}}$  is a double acceptor with charge transition levels (0/−1) at 0.3 eV and (−1/−2) at 1.0 eV above the VBM. The  $\text{Cu}_{\text{Ga}}+\text{H}$  complex [Fig. 4(b)] is a deep single acceptor with a (0/−1) level at  $E_V + 0.7$  eV. Adding the second hydrogen leads to complete passivation.  $\text{Ga}_{\text{Cu}}$  is a deep double donor with charge transition levels (+2/+) at 1.0 eV and (+/0) at 1.3 eV. The  $\text{Ga}_{\text{Cu}}+\text{H}$  complex is, again a shallow EMT donor, as explained above. In the  $\text{Ga}_{\text{Cu}}+2\text{H}$  complex shown in Fig. 5(a), the donor electron is transferred to the  $\text{H}_{\text{AB}}-\text{Ga}$  part resulting in an electrically inactive defect.

As can be seen from Fig. 6, hydrogen can give rise to shallow donor levels ( $V_{\text{Cu}}+2\text{H}$ ,  $\text{Ga}_{\text{Cu}}+\text{H}$ ) as well as to electron and hole traps ( $\text{Cu}_{\text{Ga}}+\text{H}$ ,  $\text{H}_i$ ) in CGSe, so it may influence the carrier concentration. The end effect depends on the relative concentrations. According to Eq. (1), the formation energy of H-related defects depends on the hydrogen chemical potential, which has to be chosen to reflect the conditions under which hydrogen is introduced into CGSe.

First we consider annealing in  $\text{H}_2$ , which is usually carried out between 600–850 K at 1 atm, to improve crystal quality [19,20]. The chemical potential of hydrogen in an external reservoir of  $\text{H}_2$  molecules can be calculated at a given temperature and pressure, as [67]

$$\begin{aligned} \mu_{\text{H}} = & \frac{1}{2} \{ E(\text{H}_2) + 8.617386 \times 10^{-5} T \\ & \times \ln [1.267865 \times 10^3 p T^{-(7/2)} (1 - e^{-(6.301215 \times 10^3 / T)})] \\ & + 0.2715 \}. \end{aligned} \quad (6)$$

Using this chemical potential, however, has not resulted in a significant hydrogen incorporation, so we may conclude that annealing in  $\text{H}_2$  under usual condition has no effect on the carrier concentration in CGSe.

Next, following Ref. [21], we consider internal reservoirs. (Hydrogen, introduced under nonequilibrium conditions, can form internal reservoirs of H in the crystal.) Hydrogen, incorporated during growth, saturates dangling bonds of vacancies and grain boundaries [15,16]. To simulate that, we choose the energy of hydrogen in the  $V_{\text{Cu}}+\text{H}$  complex,  $\mu_{\text{H}} = E(V_{\text{Cu}} + \text{H}) - E(V_{\text{Cu}})$ , as a possible chemical potential of the internal reservoir. Hydrogen can also be introduced by implantation of  $\text{H}^+$  or  $\text{H}_2^+$  ions [68,69], with most of the hydrogen likely ending

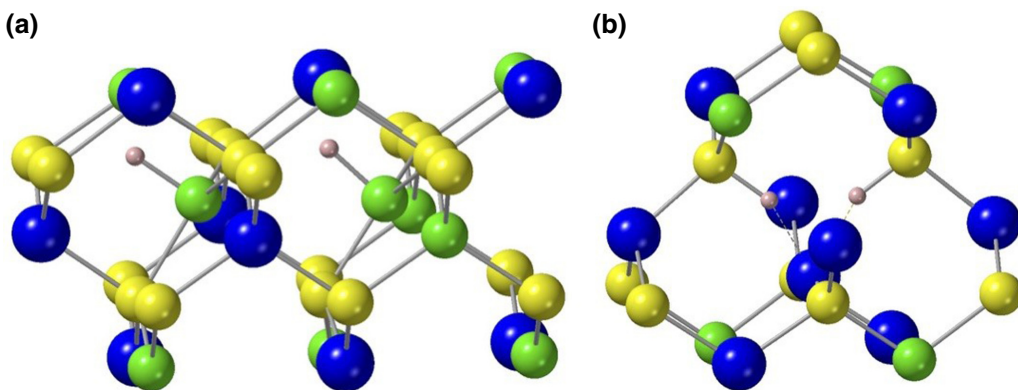


FIG. 5. Complexes  $\text{Ga}_{\text{Cu}}+2\text{H}$  (a) and  $\text{Cu}_{\text{Ga}}+2\text{H}$  (b).

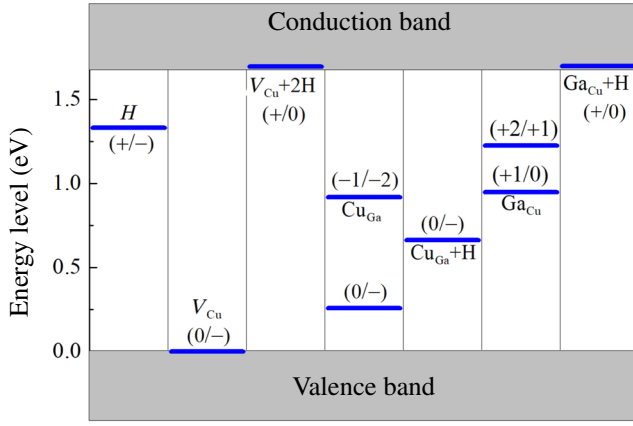


FIG. 6. Charge transition levels of the electrically active defects in hydrogenated  $\text{CuGaSe}_2$ .

up as interstitial  $\text{H}_{2i}$ . So as, an alternative for the chemical potential of the internal reservoir, we choose  $\mu_{\text{H}} = (1/2)[E(\text{H}_{2i}) - E_{\text{host}}]$ .

Hydrogen plasma treatment is a very effective way of introducing hydrogen into semiconductors [70–74]. The plasma discharge dissociates  $\text{H}_2$  molecules and provides an external source of atomic hydrogen ( $\text{H}^+ + e^-$ ). Therefore, we also investigate atomic hydrogen as an external reservoir, at the usual plasma temperature and pressure. For that, we set [66]

$$\mu_{\text{H}} = E(\text{H}) + 8.617386 \quad (7)$$

$$\times 10^{-5} T \ln(19.313058 \times p T^{-(5/2)}) \quad (8)$$

at  $T = 700$  K and  $p = 1$  kPa.

Using these  $\mu_{\text{H}}$  values, as well as the charge transition levels of Fig. 6, we calculate the formation energies according to Eq. (1) and solve Eqs. (1)–(3) by using the program of Buckeridge [75]. The results for the equilibrium Fermi-level position are shown in Table IV for the stoichiometric conditions marked A, B, and C in Fig. 2.

TABLE IV. Fermi-level position with respect to the VBM in intrinsic CGSe (considering only  $V_{\text{Cu}}$ ,  $\text{Ga}_{\text{Cu}}$ , and  $\text{Cu}_{\text{Ga}}$ , as the most abundant defects), and after hydrogen incorporation, assuming  $V_{\text{Cu}}+\text{H}$  and  $\text{H}_{2i}$  as an internal reservoir, or hydrogen atoms in the gas phase (at 700 K and 1 kPa) as external reservoir for hydrogen.

H reservoir	A (Cu poor)	B (Ga poor)	C (Se poor)
None	0.07	0.20	0.53
$V_{\text{Cu}}+\text{H}$	0.14	0.21	0.53
$\text{H}_{2i}$	0.84	0.81	0.84
H atoms at 700 K, 1 kPa	1.54	1.21	1.55

All values in eV. The stoichiometric conditions, A, B, and C, of Fig. 2 are considered.

As can be seen, hydrogen incorporation during growth (with  $V_{\text{Cu}}+\text{H}$  being the reservoir) has little effect on the Fermi-level position. Therefore, considering also our result regarding  $\text{H}_2$  annealing, unintentional H incorporation will not influence the Fermi level in CGSe much. In contrast, annealing after hydrogen implantation ( $\text{H}_{2i}$  being the internal reservoir) will result in semi-insulating material with the Fermi level around midgap. Hydrogen plasma treatment provides an external reservoir of atomic hydrogen. As Table IV shows, equilibrium with an external reservoir of atomic hydrogen pushes the Fermi level up, near to the conduction-band edge, making CGSe *n*-type. For the temperature (700 K) and pressure (1 kPa) considered here, electron concentrations will be in the order of  $10^{18} \text{ cm}^{-3}$  in Cu- and Se-poor, and  $10^{16} \text{ cm}^{-3}$  in Ga-poor samples. Therefore, a hydrogen plasma treatment (i.e., an external source of atomic hydrogen) is not only the most effective way for hydrogenation but leads to *n*-type conductivity. The mechanism of that can be understood based on Fig. 7, which shows the formation energies of all defects, with respect to atomic H as an external reservoir.

The negative formation energies of the neutral (electrically inactive)  $\text{H}_{2i}$ ,  $V_{\text{Cu}}+\text{H}$ , and  $\text{Cu}_{\text{Ga}}+2\text{H}$  defects show that atomic hydrogen is not stable with respect to molecule formation or against saturating dangling bonds (both leading to energy gain with respect to atomic hydrogen in the external reservoir). These results show, how an internal reservoir of hydrogen arises, but they do not mean an infinite hydrogen uptake. On the one hand, the number of dangling-bond defects is limited. On the other, while  $\text{H}_{2i}$  can be abundant (just as in silicon) [69,70], with increasing concentration the formation energy (given here in the solute limit) also increases, due to the increasing elastic strain, and that sets a limit to solubility. (It should be noted, that the Boltzmann statistics, used in Eqs. (1)–(3), also assumes noninteracting defects.)

In fact, under *p*-type conditions, the shallow donor  $V_{\text{Cu}}+2\text{H}$  becomes dominant over  $\text{H}_{2i}$ , as can be seen in Fig. 7. These defects diminish also the concentration of  $V_{\text{Cu}}$  acceptors and overcompensate the hole concentration provided by the rest. The position of the Fermi level is primarily determined by  $V_{\text{Cu}}$  and  $V_{\text{Cu}}+2\text{H}$  under Cu- and Se-poor conditions (A and C, respectively), while under Ga-poor conditions (B) by the  $\text{Cu}_{\text{Ga}}+\text{H}$  acceptors and the  $V_{\text{Cu}}+2\text{H}$  donors. (The defects  $\text{Ga}_{\text{Cu}}+\text{H}$  and  $\text{H}_{\text{AB}}$  have relatively high formation energies, while  $\text{H}_{2i}$ ,  $V_{\text{Cu}}+\text{H}$ ,  $\text{Cu}_{\text{Ga}}+2\text{H}$  and  $\text{Ga}_{\text{Cu}}+2\text{H}$  are neutral and inactive.) The Fermi level is pinned at 1.54, 1.21, and 1.55 eV, under Cu-, Ga-, and Se-poor conditions. These values all mean a Fermi-level position above midgap, making CGSe *n*-type. In the Cu- and Se-poor cases, the Fermi level is close enough to the conduction band to give rise to a reasonably high concentration of free electrons. Therefore, hydrogenation of Cu- or Se-poor CGSe by providing atomic hydrogen as an external source, e.g., by

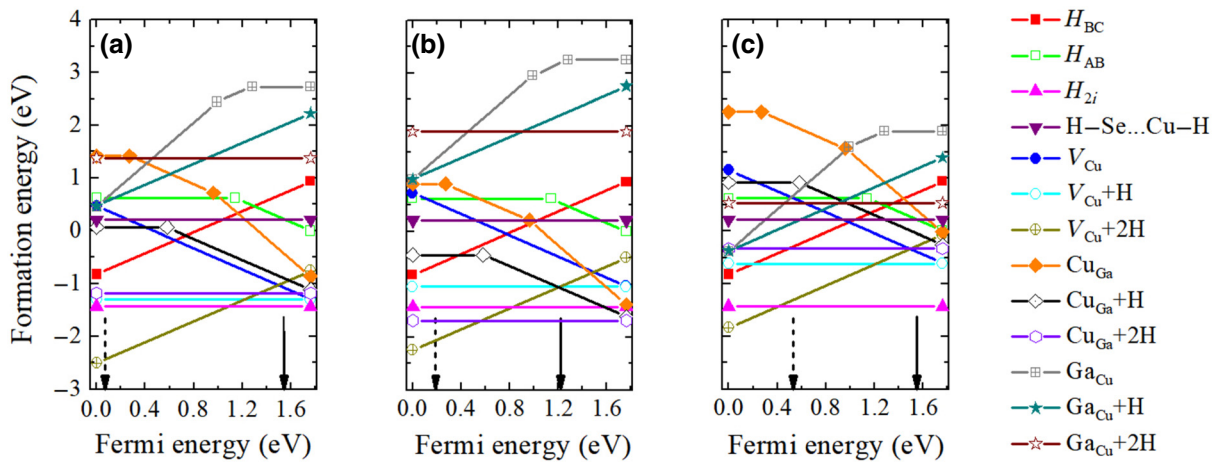


FIG. 7. Formation energies of the intrinsic and H-related defects in CuGaSe<sub>2</sub> assuming the stoichiometric conditions A (Cu poor), B (Ga poor), and C (Se poor), as described in Fig. 2. Atomic H is taken as external hydrogen reservoir. The dashed and the solid arrow show the Fermi level in native and in H-doped CuGaSe<sub>2</sub>.

a H-plasma treatment, could be used to produce *n*-type conductivity.

#### IV. SUMMARY

We perform a systematic computational study of the effect of hydrogen on CuGaSe<sub>2</sub>. We find that besides interstitial H<sub>i</sub> and H<sub>2i</sub>, hydrogen can form a defect complex with the most abundant native defects V<sub>Cu</sub>, Cu<sub>Ga</sub>, and Ga<sub>Cu</sub>. Our most useful finding is that hydrogen does not only passivate intrinsic defects but can produce shallow donor states as well. This affects the position of the Fermi level, i.e., the type of conductivity. We show that hydrogen does not get easily incorporated during usual process steps, but hydrogen implantation can produce semi-insulating material, while a hydrogen plasma treatment (providing for atomic hydrogen) can turn CuGaSe<sub>2</sub> *n*-type, mainly by the formation of shallow donor V<sub>Cu</sub>+2H defects. The *n*-type doping by hydrogen is more effective under Cu- or Se-poor conditions and less in Ga-poor material.

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- Correction:* The sentence preceding Eq. (1) was erroneously omitted during the production process and has been restored. The names of complexes were set improperly during the production process in various locations in text and have been fixed.